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U.S. **UTILITY** Patent Application

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**APPLICANTS: Echizen Hiroshi, Takai Yasuyosh	
Toshihiro; Echizen Hiroshi; Tokai Yasuyashi; Tsuzuki Hia	tetoh.
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ITLE : Sputtering method and sputtering apparatus	U.S.DEPT. OF COMM /PAT & TM-PTO-436L(Rev. 12-94)

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